



IN THE UNITED STATES PATENT & TRADEMARK OFFICE
Before the Primary Examiner

1.745

4/p
12.11.2002

Re Application of:)
JAMES R. KAHN et al.)
Serial No. 09/766,069)
Filed: January 19, 2001)
For: APPARATUS FOR SPUTTER DEPOSITION)

Group Art Unit: 1745

Examiner: J. A. Mercado

Attorney Docket No. 353-05

Hon. Commissioner for Patents
Washington, D.C. 20231

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DEC 06 2002

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AMENDMENT

Responsive to the Office Action mailed October 3, 2002,
applicant hereby amends the above identified application as
follows:

In the Claims

Please amend claim 8 to read as follows:

8. A sputtering apparatus as defined in claims 1,4, or 5
in which said sputter target is enclosed by a target enclosure,
where said target enclosure defines a portion of said sputter
target that is exposed for sputtering.

Remarks

Reconsideration is requested.

The Examiner has rejected claims 4-13 and 16 under 35
U.S.C. 112, second paragraph, as being allegedly indefinite in
certain respects. The attached Declaration of Harold R.
Kaufman explains that the phrases used in these claims are
fully supported and defined in the specification. Accord